WHAT IS CLAIMED IS:

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- 1. A solution treatment apparatus, comprising:
- a treatment solution tank configured to store a treatment solution in which a substrate is to be immersed;
 - a first electrode in electrical contact with the substrate immersed in the treatment solution;
 - a second electrode disposed in said treatment solution tank, a voltage being applied between said second electrode and said first electrode;
 - a diaphragm disposed between the substrate and said second electrode; and
 - a diaphragm position varying mechanism configured to partly vary a position of said diaphragm.
- 2. A solution treatment apparatus as set forth in claim 1, wherein, in a state before the position of said diaphragm is partly varied, a portion of said diaphragm facing a center portion of the substrate is positioned closer to a substrate side than a portion of said diaphragm facing a periphery portion of the substrate.
 - 3. A solution treatment apparatus as set forth in claim 1, wherein said diaphragm position adjusting mechanism moves a portion of said diaphragm facing a center portion of the substrate.
 - 4. A solution treatment apparatus as set forth in claim 1, further comprising a controller configured to control said diaphragm position varying mechanism.
 - 5. A solution treatment apparatus as set forth in claim 4, further comprising a sensor configured to partly measure a degree of solution treatment applied on the substrate,

wherein said controller controls said diaphragm position varying mechanism based on a result of the measurement by said sensor.

- 6. A solution treatment apparatus as set forth in claim 4, further comprising:
- a measurement substrate having a plurality of electrodes;

an ammeter configured to measure a current passing through each of the electrodes, wherein said controller controls said diaphragm position varying mechanism based on a result of the measurement by said ammeter.

7. A solution treatment apparatus, comprising:

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- a treatment solution tank configured to store a treatment solution in which a substrate is to be immersed;
- a first electrode in electrical contact with the substrate immersed in the treatment solution;

a second electrode disposed in said treatment solution tank, a voltage being applied between said first electrode and said second electrode; and

a diaphragm disposed between the substrate and said second electrode, a portion of said diaphragm facing a center portion of the substrate being positioned closer to a substrate side than a portion of said diaphragm facing a periphery portion of the substrate.

8. A solution treatment method, comprising:

immersing a substrate in a treatment solution in a treatment solution tank and passing a current through the immersed substrate to apply solution treatment on the substrate; and

partly measuring a degree of the solution treatment applied on the substrate while the solution treatment is being applied on

the substrate, and partly varying a position of a diaphragm disposed in the treatment solution tank based on a result of the measurement, to adjust the degree of the solution treatment in the substrate.

9. A solution treatment method, comprising:

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immersing a measurement substrate having a plurality of electrodes in a treatment solution in a treatment solution tank and passing a current through each of the electrodes of the immersed measurement substrate to apply solution treatment on the measurement substrate while measuring the current passing through each of the electrodes;

immersing a substrate in the treatment solution in the treatment solution tank and passing a current through the immersed substrate to apply solution treatment on the substrate; and

partly varying a position of a diaphragm disposed in the treatment solution tank based on a result of the measurement while the solution treatment is being applied on the substrate, to adjust a degree of the solution treatment in the substrate.